



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 24, 2026

IGI Report Number

LG819624469

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

HEXAGONAL MODIFIED STEP CUT

Measurements

13.33 X 6.37 X 3.88 MM

GRADING RESULTS

Carat Weight

2.59 CARATS

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

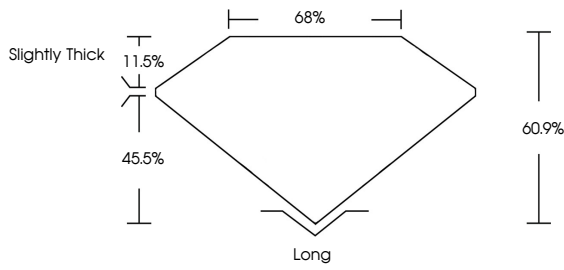
Inscription(s)

 LG819624469

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

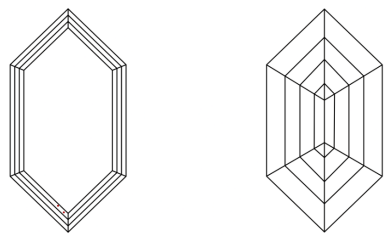
Report verification at igi.org

PROPORTIONS



Long

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
---	---	---	---	---	---	---	-------	------------	-------

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



© IGI 2020, International Gemological Institute

FD - 10 20

LABORATORY GROWN DIAMOND REPORT



July 24, 2026

IGI Report Number

LG819624469

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

HEXAGONAL MODIFIED STEP CUT

Measurements

13.33 X 6.37 X 3.88 MM

GRADING RESULTS

Carat Weight

2.59 CARATS

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG819624469

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa



IGI

July 24, 2026

IGI Report No LG819624469

HEXAGONAL MODIFIED STEP CUT

13.33 X 6.37 X 3.88 MM

Carat Weight

2.59 CARATS

Color Grade

E

Clarity Grade

VVS 2

Depth

45.5%

Table

68%

Girdle

Slightly Thick

Culet

Long

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG819624469

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa